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FORM FO-1449	SERIAL NO.	CASE NO.
	10/047,469	10322/31
LIST OF PATENTS AND PUBLICATIONS FOR	FILING DATE	GROUP ART UNIT
APPLICANT'S INFORMATION DISCLOSURE STATEMENT	January 15, 2002	2817
(use several sheets if necessary) APPLICANT(S): J. Gary Eden et al.		

REFERENCE DESIGNATION U.S. PATENT DOCUME

REFERENCE	DESIG		PATENT DOC	UMEN 15		
EXAMINER INITIAL		DOCUMENT NUMBER Number-Kind Code (If known)	DATE	NAME	CLASS/ SUBCLASS	FILING DATE
D-77.	B1	6,139,384	10/31/2000	DeTemple et al.		
D.D.	B2	6,082,294	07/04/2000	Simpson		
D.D.	В3	5,939,829	08/17/1999	Schoenbach et al.		
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FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER Number-Kind Code (If known)	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION YES OR NO

EXAMINER INITIAL	OTHER ART – NON PATENT LITERATURE DOCUMENTS (Include name of author, title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date page(s), volume-issue number(s), publisher, city and/or country where published.					
						

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EXAMINER	L	J. : J.	DATE CONSIDERED	rl	20	104	

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Rev. Dec.-99 Document17



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EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS/ SUBCLASS	FILING DATE
D.D.	A1	6,016,027	01/2000	DeTemple et al.		
D.B.	A2	5,686,789	11/1997	Schoenbach et al.		
	<u>.</u>					

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSI YES	ATION NO
b .D.	A3	JP 7,192,701	07/1995	Japan		X (Partial)	
				,			

EXAMINER INITIAL	OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)
5.8.	A4 "High-Pressure Hollow Cathode Discharges;" Karl H. Schoenbach et al.; Physical Electronics Research Institute, Old Dominion University, Norfolk, VA, USA; 6-30-1997.
D.D.	A5 "Microdischarge Devices Fabricated in Silicon;" J.W. Frame et al.; Department of Electrical and Computer Engineering, Everett Laboratory, University of Illinois, Urbana, Illinois, USA; 6-30-1997; App. Phys. Lett. 71 (9), 1 September 1997.
D.D.	A6 "Flexible Microdischarge Arrays: Metal/Polymer Devices;" SJ. Park et al.; Laboratory for Optical Physics and Engineering, Department of Electrical and Computer Engineering, University of Illinois, Urbana, Illinois, USA; 5-17-2000; Applied Physics Letters, Volume 77, Number 2, 10 July 2000.
D.D.	47 "Emission of Excimer Radiation from Direct Current, High-Pressure Hollow Cathode Discharges;" Ahmed El-Habachi and Karl H. Schoenbach; Electrical and Computer Engineering Department, Physical Electronics Research Institute, Old Dominion University, Norfolk, Virginia, USA; 11-4-1997; App. Phys. Lett. 72 (1), 5 January 1998.
D.D.	A8 "Performance of Microdischarge Devices and Arrays with Screen Electrodes;" SJ. Park, C.J. Wagner, and J. G. Eden, Fellow, IEEE; IEEE Photonics Technology Letters, Vol. 13, No. 1, January 2001.

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